## Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination		
10/523,223	NAPPA ET AL.		
Examiner	Art Unit		
Jafar Parsa	1621		

	SEARCHED				
Class	Subclass	Date	Examiner		
570	169	10/2/2005	JP		
570	164	10/2/2005	JP		
570	166	10/2/2005	JP		
570	172	10/2/2005	JP		
570	176	10/2/2005	JP		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
570	169	10/2/2005	JP		
570	164	10/2/2005	JP		
570	172	10/2/2005	JP		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East .	10/2/2005	JP		
STN	10/2/2005	JP		
Inventor name search	10/2/2005	JP		